

Docket No.: 043890-0449

PATENT**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 20277
Hidenori KAMEI, et al. : Confirmation Number: 4504
Application No.: 09/680,943 : Group Art Unit: 2823
Filed: October 10, 2000 : Allowed: September 08, 2005
Examiner: George R. Fourson III
For: P-TYPE NITRIDE SEMICONDUCTOR AND METHOD OF
MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT**FAX RECEIVED**

Mail Stop IDS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

DEC 05 2005

OFFICE OF PETITIONS

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached form PTO-1449. It is respectfully requested that the reference be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

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Respectfully submitted,
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Signature Date 12-5-05